

9/2/2003 10/010,954

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Drafts Pending Active

L1: (14) "Patton Evan ES".in.

L3: (13) "Reid Jonathan DS".in.

L4: (6) 13 not 11

L5: (8) "Hawkins Jeffrey AS".in.

L6: (8) 15 not (11 or 13)

L7: (1) "Kalakkad Dinesh SS".in.

L8: (51) "Mayer Steven TS".in.

L9: (48) 18 not (11 or 13 or 15 or 17)

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DB: USPTO PGPUB Default operator OR

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Title	Current OR	Current XRef	Retrieval C	Inventor	S	C	E
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9/2/2003 10/010,954

[EAST] Browne - L2G [600] 25 not 24 | US 6267860 B1 | Tag: S1 Doc: 73M686 (SORTED) | Format: KWIC

	Document ID	V	Pages	1	2	3	4	5	6	7	8	9	10	S	C	P	U	Kind	Codes	Some
67	US 6280598 B1		7															USPAT	USPAT	
68	US 6280597 B1		23															USPAT	USPAT	
69	US 6274022 B1		8															USPAT	USPAT	
70	US 6274021 B1		7															USPAT	USPAT	
71	US 6270645 B1		11															USPAT	USPAT	
72	US 6267861 B1		7															USPAT	USPAT	
73	US 6267860 B1		12															USPAT	USPAT	

US-PAT-NO: 6267860

DOCUMENT-IDENTIFIER: US 6267860 B1

See image for Certificate of Correction

TITLE: Method and apparatus for electroplating

----- KWIC -----

Assistant Examiner - XA (1):
Leader, William T.Current US Original Classification - CCOR (1):
205/96

(12) United States Patent

(10) Patent No.: US 6,267,860 B1
(45) Date of Patent: Jul. 31, 2001

(11) Inventor: Brodsky, Louis William

(56) U.S. PATENT DOCUMENTS

(54) METHOD AND APPARATUS FOR ELECTROPLATING

(75) Inventor: William Louis Brodsky, Binghamton, NY (US)

(73) Assignee: International Business Machines Corporation, Armonk, NY (US)

(57) ABSTRACT

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(d) by 0 days.

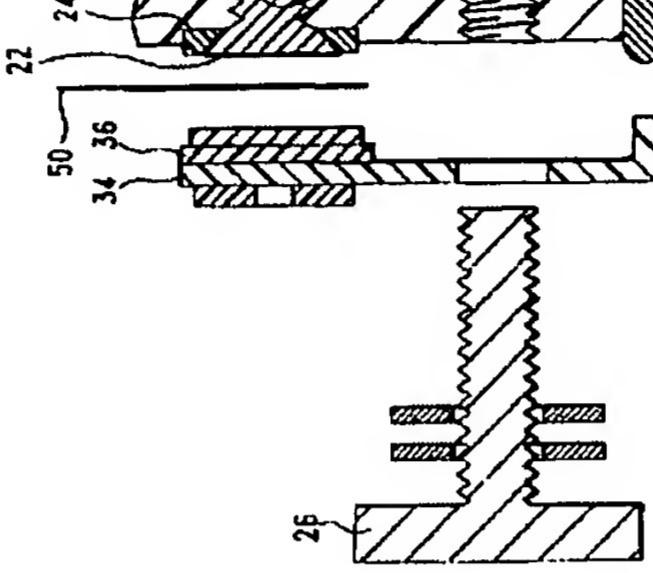
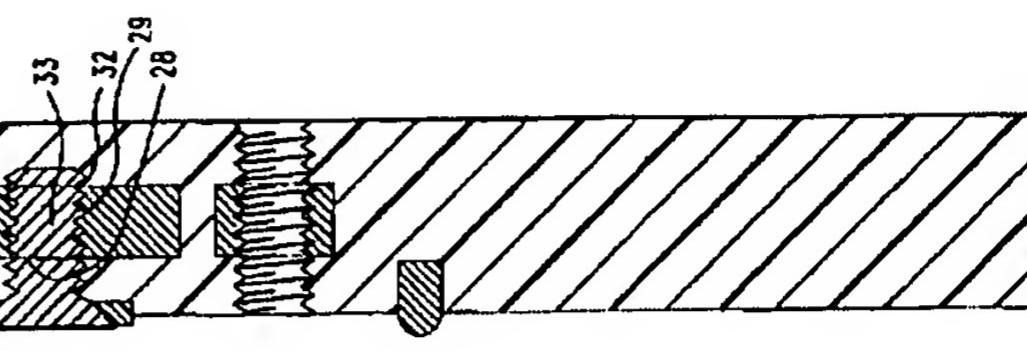
(21) Appl. No.: 09/361,728

(22) Filed: Jul. 27, 1999

(51) Int. Cl.' C25D 17/04

(52) U.S. Cl. 205/96; 204/230.2; 204/297.06;

(58) Field of Search 205/96; 204/230.2; 204/297.1; 204/297.13; 204/DIG. 7

(54) Primary Examiner—Kathryn Gorges
Assistant Examiner—William T. Leader
(74) Attorney, Agent, or Firm—Connolly, Bove, Lodge & Hutz, LLP; Lawrence R. Fraley, Esq.

(57) ABSTRACT

(54) Electrolytic plating of a workpiece is enhanced by providing a resistor between the workpiece and electrically conductive support member.

(57) 19 Claims, 6 Drawing Sheets

Start	Stop	Index	Explain..	Classify..	New ca..	034 p..	034 d..	034 f..	034 s..	034 t..	034 c..	034 r..	034 m..	034 l..	034 n..	034 o..	034 g..	034 h..	034 i..
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	Document ID	V	Pages	1	2	3	4	U	S	C	P	Kind Codes	\$ourc
2	US 6193859 B1	C1		□	□	□	□	□	□	□	□	USPAT	
3	US 6179983 B1		12	□	□	□	□	□	□	□	□	USPAT	
4	US 6162344 A	B		□	□	□	□	□	□	□	□	USPAT	
5	US 6126798 A	A	12	□	□	□	□	□	□	□	□	USPAT	
6	US 6110346 A	A	8	□	□	□	□	□	□	□	□	USPAT	
7	US 6074544 A	A	18	□	□	□	□	□	□	□	□	US-PG	
8	US 20020108862 A	A	13	□	□	□	□	□	□	□	□	US-PG	
11													

US-PAT-NO: 6193859
 DOCUMENT-IDENTIFIER: US 6193859 B1
 TITLE: Electric potential shaping apparatus for holding a semiconductor wafer during electroplating

----- RWIC -----

Brief Summary Text - BSTX (11):
 In accordance with the present invention, an apparatus for depositing an electrically conductive layer on the surface of a substrate such as a wafer comprises a flange. The flange has a cylindrical wall and an annulus extending inward from the cylindrical wall, the annulus having an inner perimeter which defines a flange central aperture. The apparatus also includes a cup for supporting the wafer along a peripheral region thereof. The cup has a cup central aperture defined by an inner perimeter of the cup, the cup being positioned above the flange.

Brief Summary Text - BSTX (12):
 In one embodiment, the diameter of the flange central aperture is less than the diameter of the cup central aperture. The annulus of the flange thus extends under the edge region of the wafer surface and reduces the electric current flux to this edge region during electroplating. This, in turn, reduces the thickness of the deposited electrically conductive layer on the edge region of the wafer surface. Of importance, the thickness of the deposited electrically conductive layer on the edge region of the wafer surface is reduced without the use of thieves.

Brief Summary Text - BSTX (14):
 The flange can further include a plurality of apertures extending through the cylindrical wall of the flange. By locating these apertures adjacent the cup end near the edge region of the wafer surface, air bubbles entrapped on the wafer surface can readily escape through the apertures. To further enhance removal of entrapped air bubbles, the wafer can be rotated while the plating solution is directed towards the center of the wafer surface.

Brief Summary Text - BSTX (16):
 In accordance with another embodiment of the present invention, a method of depositing an electrically conductive layer on the wafer surface includes providing a cup attached to a flange, the cup having an inner perimeter which defines a cup central aperture, the flange having an annulus. The wafer is then mounted in the cup so that the wafer surface is exposed through the cup central aperture. The cup and flange are then placed into a plating solution, the plating solution contacting the wafer surface. An electrical field and electric current flux is then produced between the wafer surface and an anode in the plating solution wherein the annulus of the flange shapes the electric current flux and reduces the thickness of the deposited electrically conductive layer on the edge region of the wafer surface.

(12) United States Patent (10) Patent No: US 6,193,859 B1
 Contolini et al. (45) Date of Patent: Feb. 27, 2001

(54) ELECTRIC POTENTIAL SHAPING APPARATUS FOR HOLDING A SEMICONDUCTOR WAFER DURING ELECTROPLATING

(75) Inventor: Robert J. Contolini, Lake Oswego; Jonathan Reid, Sherwood; Evan Patton, Portland; Jingbin Feng, Tigard; Steve Tastles, West Linn, all of OR (US); John Owen Dukovic, Pleasantville, NY (US)

(73) Assignee: Novellus Systems, Inc., San Jose, CA (US); International Business Machines Corporation, Armonk, NY (US)

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

(List continued on next page.)

OTHER PUBLICATIONS

"Upside-Down Resist Coating of Semiconductor Wafers", IBM Technical Disclosure Bulletin, vol. 32, No. 1, Jun. 1989, pp. 311-313.
 Evan E. Patton, et al., "Automated Gold Plate-Up Bath Scope Document and Machine Specifications", Tektronix Confidential, dated Aug. 4, 1989, pp. 1-13.

Primary Examiner—Donald R. Valentine
 (74) Attorney, Agent, or Firm—Sleevren Martill MacPherson LLP; David E. Siegert
 (57) ABSTRACT
 An apparatus for depositing an electrically conductive layer on the surface of a wafer comprises a flange. The flange has a cylindrical wall and an annulus attached to a first end of the cylindrical wall. The annulus shields the edge region of the wafer surface during electroplating reducing the thickness of the deposited electrically conductive layer on the edge region. Further, the cylindrical wall of the flange can be provided with a plurality of apertures adjacent the wafer surface to allow gas bubbles entrapped on the wafer surface to readily escape.

29 Claims, 12 Drawing Sheets

(21) Appl. No.: 09/074,624

(22) Filed: May 7, 1998

Related U.S. Application Data

(62) Division of application No. 08/970,120, filed on Nov. 13, 1997, now Pat. No. 6,193,54.

(51) Int. Cl.: C25D 17/00; C25B 9/00

(52) U.S. Cl.: 204/224 R, 204/279

(58) Field of Search: 204/237, 279, 205/157, 96

(56) References Cited

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4,137,867 • 2/1979 Ago 118/627

4,170,959 • 10/1979 Ago 118/627

4,246,088 • 1/1981 Murphy et al. 205/151 X

4,259,166 • 3/1981 Whitehurst 204/279

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4,304,641 • 12/1981 Granda et al. 156/345

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4,339,319 • 7/1982 Ago 204/224

Drawing Description Text - DRTX (3):

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	Document ID	Pages	1	2	3	U	S	C	P	Kind Codes	Sous-	USPAT
1	US 6627052 B2	10	✓	✓	✓	✓	✓	✓	✓			USPAT
2	US 6193859 B1	21	□	□	□	□	□	□	□			USPAT
3	US 6179983 B1	12	□	□	□	□	□	□	□			USPAT
4	US 6162344 A	9	□	□	□	□	□	□	□			USPAT
5	US 6126798 A	12	□	□	□	□	□	□	□			USPAT
6	US 6110346 A	8	□	□	□	□	□	□	□			USPAT
7	US 6074544 A	8	□	□	□	□	□	□	□			USPAT

US-PAT-NO: 6627052
DOCUMENT-IDENTIFIER: US 6627052 B2
TITLE: Electroplating apparatus with vertical electrical contact

Brief Summary Text - BSTX (5):
The present inventors believe that contact arrangements used in a typical electroplating apparatus cause slight imperfections on the copper (Cu) seed layer during plating. These known contact arrangements have contact points located, for example, at the ends of 128 short "arms." These arms take up compression when, e.g., sealing the wafer in a "clamshell" for electroplating. See, for example, known electroplating tools such as the SABRE Electro-fill System marketed by Novellus Systems, Inc., San Jose, Calif. See, also, U.S. Pat. No. 6,074,544 (Method Of Electroplating Semiconductor Wafer Using Variable Currents And Mass Transfer To Obtain Uniform Plated Layer) and U.S. Pat. No. 6,139,712 (Method Of Depositing Metal Layer), which are both incorporated in their entireties herein by reference. When a Cu seed layer is greater than 1000 Å thickness, these contacts don't pose a serious problem. However, as the industry moves to thinner and thinner seed layers, these contacts do enough damage to cause large variations in plated film thickness. Having the actual contact point located at the end of a "moment arm" induces certain, but slight, amount of motion in the "x" direction in order to accommodate for the "z" motion required for sealing the wafer in the clamshell for electroplating. When the movement in the "x" direction occurs, it scratches across the seed layer reducing the number of good electrical connections.

Detailed Description Text - DETX (B):
The present inventors believe that known contact arrangements cause slight imperfections on the copper (Cu) seed layer during plating. These known contact arrangements have contact points located at the ends of, eg, 120 short "arms." These arms take up compression when, eg, sealing the wafer in a "clamshell" for electroplating. See, for example, known electroplating tools such as the SABRE Electro-fill system marketed by Novellus Systems, Inc., San Jose, Calif. See, also, previously incorporated U.S. Pat. Nos. 6,074,544 and 6,139,712. When the Cu seed layer is greater than 1000 Å thickness, this doesn't pose a problem. However, as the industry moves to thinner and thinner seed layers, these contacts do enough damage to cause large variations in plated film thickness. Having the actual contact point located at the end of "moment arm" induces a certain, be it slight, amount of motion in the "x" direction in order to accommodate for the "z" motion required for sealing the wafer in the clamshell for electroplating. When the movement in the "x" direction occurs, it scratches across the seed layer reducing the number of good electrical connections.

Detailed Description Text - DETX (11):
 FIG. 3 is a diagrammatical view of an electroplating apparatus 30 having a wafer 36 mounted therein, and a vertically movable contact carrier C with fixed electrical contacts (eg, contact pins) in accordance with the present

5 Alternatively, a single contact (e.g., an electrically conductive elastomer) could continuously engage a substrate about its perimeter. According to the present invention, a plurality of contacts could be arranged around the substrate. The plurality of contacts could all be separate structures. Such contacts may be considered to be discontinuous.

As can be seen in FIG. 5B, press fitted pin contacts according to the present invention can provide electrical contact to a substrate without damaging any of the upper surface of the substrate where material is to be electrodeposited.

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The shape of a contact according to the present invention may vary, depending upon the embodiment, but tends to make either single point contact (e.g., pin 11, 11A) or continuous contact (e.g., conductive elastomer). FIGS. 6, 7A and 7B illustrate various examples of embodiments of contacts according to the present invention. In the case of the straight pins or "unbuckled beam," (FIG. 7A), they could be backed with corrosion resistant conductive rubber to take up the compression of the clamshell and to tie all 128 pins to a common connection. In the case of the "buckled beam" (FIG. 7B), all pins should be wired together (shorted) before effecting the connection to the negative output lead of the DC power supply 65.

single points where the contacts touch the seed layer. On the other hand, the conductive elastomer, CE embodiment illustrated in FIG. 5C may make contact all along its length with the seed layer and the substrate. The conductive elastomer CE having conductive filler 11E is, e.g., a CHO-SEAL conductive elastomer marketed by Chromerics, Inc., Weburn, Mass.

In addition to varying the number, arrangement, and shape of the contacts, the structure of the contacts may also vary. Along these lines, the composition of the contacts may vary. According to some embodiments, the contacts may be made of copper. According to other embodiments, the contacts may be made of stainless steel. The contact or contacts may also be made of other materials. Along these lines, the contact(s) may also include a mixture of copper and beryllium.

Additionally, portions of the contacts may be made of other materials. For example, the entire contact or just a portion of the contact that contacts the substrate and/or seed layer may be coated with another material. For example, the

contact or portion of the contacts that engage this second layer and/or substrate may have a coating of α -Ta, nitrides of tantalum, gold, rhodium, and/or titanium nitride with Ti overlay, in other words, $Ti/TiN/Ti$. Examples of nitrides of tantalum include hexagonal-Ta_N and cubic-Ta_N. Regardless of the composition of the contacts, they may include alternative embodiments.

What is claimed is:

1. An apparatus for depositing material on a surface of a substrate, comprising:

at least one electrical contact movable only in a vertical direction for engagement with said surface of said

be coated with another material. For example, the contacts may be coated with an elastomeric coating, such as VITON, or polymers, such as PTFE or PVDF (polyvinylidene fluoride) and their like. The U polymer coating may be deposited on the contacts in order to prevent wasteful metal deposition in this region.

33 ■ voltage source connected to said at least one electrical contact, wherein said at least one electrical contact is a buckled beam contact.

2. An apparatus for depositing material on a surface of a substrate comprising:

Whether a contact is made of copper, stainless steel, or any other electrically conductive material(s), such contacts so could be coated with α -Ta, nitrides of tantalum, gold, rhodium, and/or titanium nitride with Ti overlay, an elastomeric or non-elastomeric polymer coating and/or any other voltage source connected to said at least one electrical substrate, comprising:

contact, wherein said at least one electrical contact comprises an electrically conductive elastomer.

3. An apparatus for depositing material on a surface of a substrate, comprising:

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plated. A voltage source may be connected to the H lead one contact. The contacts and plating apparatus may be provided substantially as described above. Two at least one contact may be biased into contact with the substrate.

A corner of the substrate may also be engaged by the at least one contact. Also, the contact may be used to electroetch or electropolish metals on a substrate. In this case, the contacts are rendered anodic.

The foregoing description of the invention illustrates and describes the present invention. Additionally, the disclosure shows and describes only the preferred embodiments of the invention, but as aforementioned, it is to be understood that the invention is capable of use in various other combinations, modifications, and environments and is capable of changes or modifications within the scope of the inventive concept as expressed herein, commensurate with the above teachings, and/or the skill or knowledge of the relevant art. The embodiments described hereinabove are further intended to explain best modes known of practicing the invention and to enable others skilled in the art to utilize

the invention in such, or other, embodiments and with the various modifications required by the particular applications or uses of the invention. Accordingly, the description is not intended to limit the invention to the form disclosed herein. Also it is intended that the annexed claims be construed so

United States Patent [19]
Contolini et al.

Contolini et al.

[54] ELECTRIC POTENTIAL SHAPING METHOD FOR ELECTROPLATING

[75] Inventors: Robert J. Cantolini, Lake Oswego; Jonathan Rebb, Sherwood; Evan Paton, Portland; Jingbin Feng, Tigard; Steve Taatjes, West Linn, all of Oregon; John Owen Dukovic, Pleasantville, New York.

UG-PAT-NO: 6159354
DOCUMENT-IDENTIFIER: UG 6159354 A
for download see instructions

U.S. Patent No. - PN (1):
6159354

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CONTINUATION

Open-Source Against Copyright Law, vol. 32, No. 1, Jun. 1889, pp. 311-313.

Evan E. Patton, et al., "Automated Gold Plate-Up Bath Scope Document and Machine Specifications", Tektronix

Tektronix Invention Disclosure Form (Company Confidential), not dated, 4 pages.

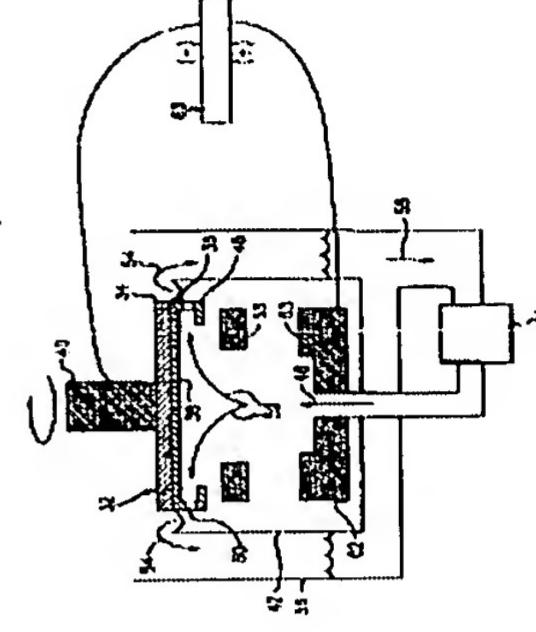
**Primary Examiner—Donald R. Valentine
Attorney, Agent, or Firm—Skjerven, Morrill, MacPhee & Peterson.**

Friedrich and FREI [57] ABSTRACT

An apparatus for depositing an electrically conductive layer on the surface of a wafer comprises a flange. The flange has

a cylindrical wall and an annulus attached to said cylindrical wall. The annulus shields the edge region of the wafer surface during electroplating reducing the thickness of the deposited electrically conductive layer on the edge region. Further, the cylindrical wall of the flange can be provided with a plurality of apertures adjacent the wafer allowing gas bubbles entrapped on the wafer surface to readily escape.

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12. Giant 12 Days Sheet

9/2003 10/010,954

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US-PAT-NO:	4923583
DOCUMENT-IDENTIFIER:	US 4923583 A
TITLE:	Electrode elements for filter press membrane electrolytic cells
RWIC -	-----

Document ID		Pages	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31	32	33	34	35	36	37	38	39	40	41	42	43	44	45	46	47	48	49	50	51	52	53	54	55	56	57	58	59	60	61	62	63	64	65	66	67	68	69	70	71	72	73	74	75	76	77	78	79	80	81	82	83	84	85	86	87	88	89	90	91	92	93	94	95	96	97	98	99	100	101	102	103	104	105	106	107	108	109	110	111	112	113	114	115	116	117	118	119	120	121	122	123	124	125	126	127	128	129	130	131	132	133	134	135	136	137	138	139	140	141	142	143	144	145	146	147	148	149	150	151	152	153	154	155	156	157	158	159	160	161	162	163	164	165	166	167	168	169	170	171	172	173	174	175	176	177	178	179	180	181	182	183	184	185	186	187	188	189	190	191	192	193	194	195	196	197	198	199	200	201	202	203	204	205	206	207	208	209	210	211	212	213	214	215	216	217	218	219	220	221	222	223	224	225	226	227	228	229	230	231	232	233	234	235	236	237	238	239	240	241	242	243	244	245	246	247	248	249	250	251	252	253	254	255	256	257	258	259	260	261	262	263	264	265	266	267	268	269	270	271	272	273	274	275	276	277	278	279	280	281	282	283	284	285	286	287	288	289	290	291	292	293	294	295	296	297	298	299	300	301	302	303	304	305	306	307	308	309	310	311	312	313	314	315	316	317	318	319	320	321	322	323	324	325	326	327	328	329	330	331	332	333	334	335	336	337	338	339	340	341	342	343	344	345	346	347	348	349	350	351	352	353	354	355	356	357	358	359	360	361	362	363	364	365	366	367	368	369	370	371	372	373	374	375	376	377	378	379	380	381	382	383	384	385	386	387	388	389	390	391	392	393	394	395	396	397	398	399	400	401	402	403	404	405	406	407	408	409	410	411	412	413	414	415	416	417	418	419	420	421	422	423	424	425	426	427	428	429	430	431	432	433	434	435	436	437	438	439	440	441	442	443	444	445	446	447	448	449	450	451	452	453	454	455	456	457	458	459	460	461	462	463	464	465	466	467	468	469	470	471	472	473	474	475	476	477	478	479	480	481	482	483	484	485	486	487	488	489	490	491	492	493	494	495	496	497	498	499	500	501	502	503	504	505	506	507	508	509	510	511	512	513	514	515	516	517	518	519	520	521	522	523	524	525	526	527	528	529	530	531	532	533	534	535	536	537	538	539	540	541	542	543	544	545	546	547	548	549	550	551	552	553	554	555	556	557	558	559	560	561	562	563	564	565	566	567	568	569	570	571	572	573	574	575	576	577	578	579	580	581	582	583	584	585	586	587	588	589	590	591	592	593	594	595	596	597	598	599	600	601	602	603	604	605	606	607	608	609	610	611	612	613	614	615	616	617	618	619	620	621	622	623	624	625	626	627	628	629	630	631	632	633	634	635	636	637	638	639	640	641	642	643	644	645	646	647	648	649	650	651	652	653	654	655	656	657	658	659	660	661	662	663	664	665	666	667	668	669	670	671	672	673	674	675	676	677	678	679	680	681	682	683	684	685	686	687	688	689	690	691	692	693	694	695	696	697	698	699	700	701	702	703	704	705	706	707	708	709	710	711	712	713	714	715	716	717	718	719	720	721	722	723	724	725	726	727	728	729	730	731	732	733	734	735	736	737	738	739	740	741	742	743	744	745	746	747	748	749	750	751	752	753	754	755	756	757	758	759	760	761	762	763	764	765	766	767	768	769	770	771	772	773	774	775	776	777	778	779	780	781	782	783	784	785	786	787	788	789	790	791	792	793	794	795	796	797	798	799	800	801	802	803	804	805	806	807	808	809	810	811	812	813	814	815	816	817	818	819	820	821	822	823	824	825	826	827	828	829	830	831	832	833	834	835	836	837	838	839	840	841	842	843	844	845	846	847	848	849	850	851	852	853	854	855	856	857	858	859	860	861	862	863	864	865	866	867	868	869	870	871	872	873	874	875	876	877	878	879	880	881	882	883	884	885	886	887	888	889	890	891	892	893	894	895	896	897	898	899	900	901	902	903	904	905	906	907	908	909	910	911	912	913	914	915	916	917	918	919	920</th

Detailed Description Text - DETX (9):
As each substrate is plated, and over multiple substrate plating cycles, the contact-pin-substrate interface resistance still may vary, eventually reaching an unacceptable value. An electronic sensor/alarm 60 can be connected across the external resistor 58 to monitor the voltage/current across the external resistor to address this problem. If the voltage/current across any external resistor 58 falls outside of a preset operating range that is indicative of a high pin-substrate resistance, the sensor/alarm 60 triggers corrective measures such as shutting down the plating process until the problems are corrected by an operator. Alternatively, a separate power supply can be connected to each contact pin and can be separately controlled and monitored to provide a uniform current distribution across the substrate.

Claims Text - CLTX (19):
b) a cathode electrically contacting the substrate plating surface, wherein the cathode comprises a cathode contact member disposed at a peripheral portion of the substrate plating surface, the cathode contact member having a contact surface adapted to electrically contact the substrate surface, wherein the cathode contact member comprises a radial array of contact pins and a resistor connected in series with each contact pin;

Current US Cross Reference Classification - CCXR (12):
205/123

Current US Cross Reference Classification - CCXR (16):
205/157

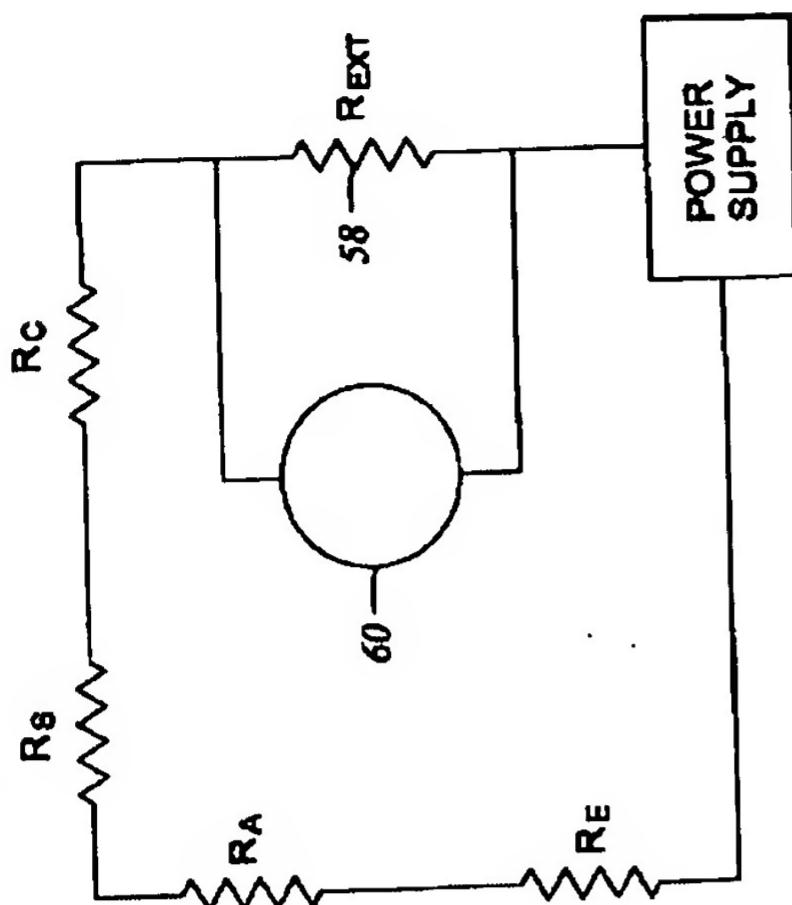
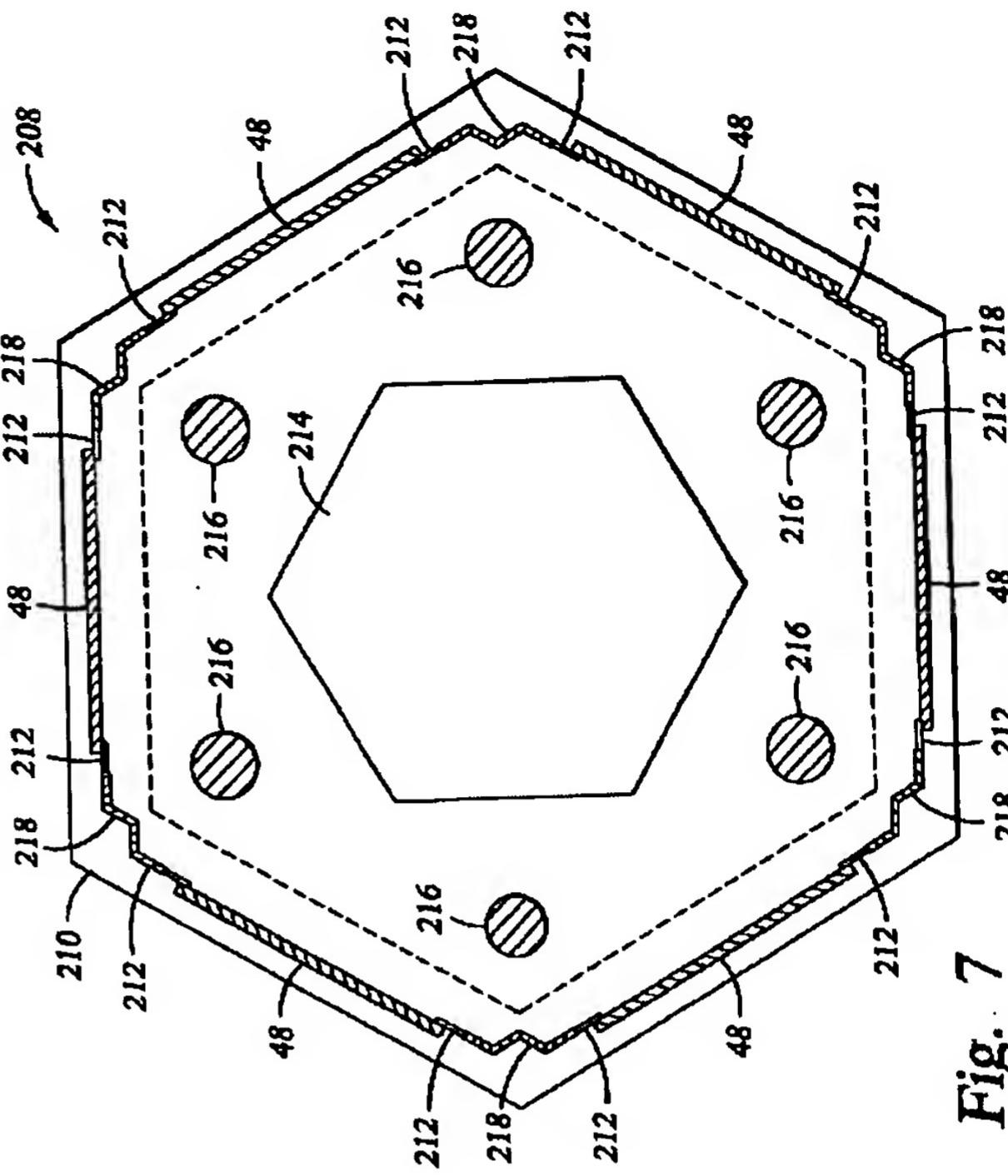


Fig. 4



7

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[EAST • Default EAST Workspace [Flat Panel LANDSCAPE].wsp:1]

<input type="checkbox"/> Search	<input type="checkbox"/> Link	<input type="checkbox"/> Browse	<input type="checkbox"/> Queue	<input type="checkbox"/> Clear
[4] <input type="checkbox"/> Print				
<input type="checkbox"/> Print				
<input checked="" type="checkbox"/> Highlight all link terms initially				
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9/2003

Several FCSI Workgroups [flat Panel | ANDSCAPE] were

The screenshot displays a software application window with the following components:

- Top Bar:** Includes "File", "View", "Edit", "Tools", "Window", "Help" menu items, and icons for "New", "Open", "Save", "Print", "Find", "Copy", "Paste", "Delete", "Search", "Help", and "Exit".
- Left Sidebar:** Contains navigation links for "Drafts", "Pending", "Active", "Failed", "Saved", "Favorites", "Tagged (0)", "UDC", "Queue", and "Trash".
- Search Panel:** Features a search bar with placeholder text "Search Active Items", a dropdown for "Search Type" (set to "Exact Match"), and a "Search" button. It also includes "Clear", "Queue", and "Browse" buttons.
- Search Criteria:** A section titled "Search Criteria" with a "Search" button. It contains fields for "Text" (with placeholder "Search Active Items") and "Search Type" (set to "Exact Match").
- Search Results:** A table titled "Search Results" showing 11 results. The columns are "Title", "Current OR", "Current XRef", "Retrieval C", "Inventor", "S", "C", and "D". The first result is highlighted.
- Document View:** A large central area showing a document with the title "L1: (609) ((205/123) or (205/157)). CCLS." and several numbered sections L1 through L5. Below the document are "Print", "Email", "Text", and "HTML" buttons.
- Bottom Buttons:** Includes "Start", "Stop", "Details", "HTML", "Ready", and "Help" buttons.

9/2003 10/010,954

EASI : [Peter] EASI Workpiece [Flat Panel LANDSCAPE].wsp |

	US-PAT-NO:	6299751
DOCUMENT-IDENTIFIER:	US 6299751 B1	
TITLE:	Apparatus and method for plating wafers, substrates and other articles	

RWIC -----

(12) United States Patent

Kaufman et al.

(45) Date of Patent:

Oct. 9, 2001

(54) APPARATUS AND METHOD FOR PLATING

WAFFERS, SUBSTRATES AND OTHER ARTICLES

(75) Inventor: Robert Kaufman, Canoga Park, Gary C. Downes, Moorpark, both of CA (US)

(73) Assignee: Technic Inc., Cranston, RI (US)

(10) Patent No.: US 6,299,751 B1

(45) Date of Patent:

Oct. 9, 2001

Primary Examiner—Edna Wong

(74) Attorney, Agent, or Firm—Blankley, Schlosser, Taylor & Zafman LLP

(57) ABSTRACT

A plating apparatus and methodology is disclosed that is particularly useful in improving the plating rate, improving the plating of via holes, improving the uniformity of the plating deposition across the surface of the wafer, and minimizing damage to the wafer. With regard to improving the plating rate and the plating of via holes, the plating apparatus and method immerses a wafer in a plating fluid bath and continuously directs plating fluid towards the surface of the wafer. Immersing the wafer in a plating fluid bath reduces the occurrence of trapped gas pockets within via holes which makes it easier to plate them. The continuous directing of plating fluid towards the surface of the wafer increases the ion concentration gradient which is, in turn, increases the plating rate. With regard to improving the uniformity of the plating deposition, the plating apparatus and method effectuate random horizontal fluid flow within the bath to reduce the occurrence of relatively long horizontal fluid flow that causes non-uniform plating deposition across the surface of the wafer.

(51) Appl. No.: 09/638,982

(22) Filed: Aug. 15, 2000

(56) Related U.S. Application Data

(62) Division of application No. 09/348,768, filed on Jul. 7, 1999, now Pat. No. 6,197,182.

(51) Int. Cl.: C25D 5/20; C25D 21/10; C25D 7/00; C25D 5/08

(52) U.S. Cl.: 205/148; 205/149; 205/157; 205/133

(58) Field of Search: 427/430.1; 438/584; 438/578; 679; 680; 205/148; 149; 157; 133

(56) Reference Cited

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4,678,545 7/1987 Galik 204/15

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(74) Attorney, Agent, or Firm—Blankley, Schlosser, Taylor & Zafman LLP

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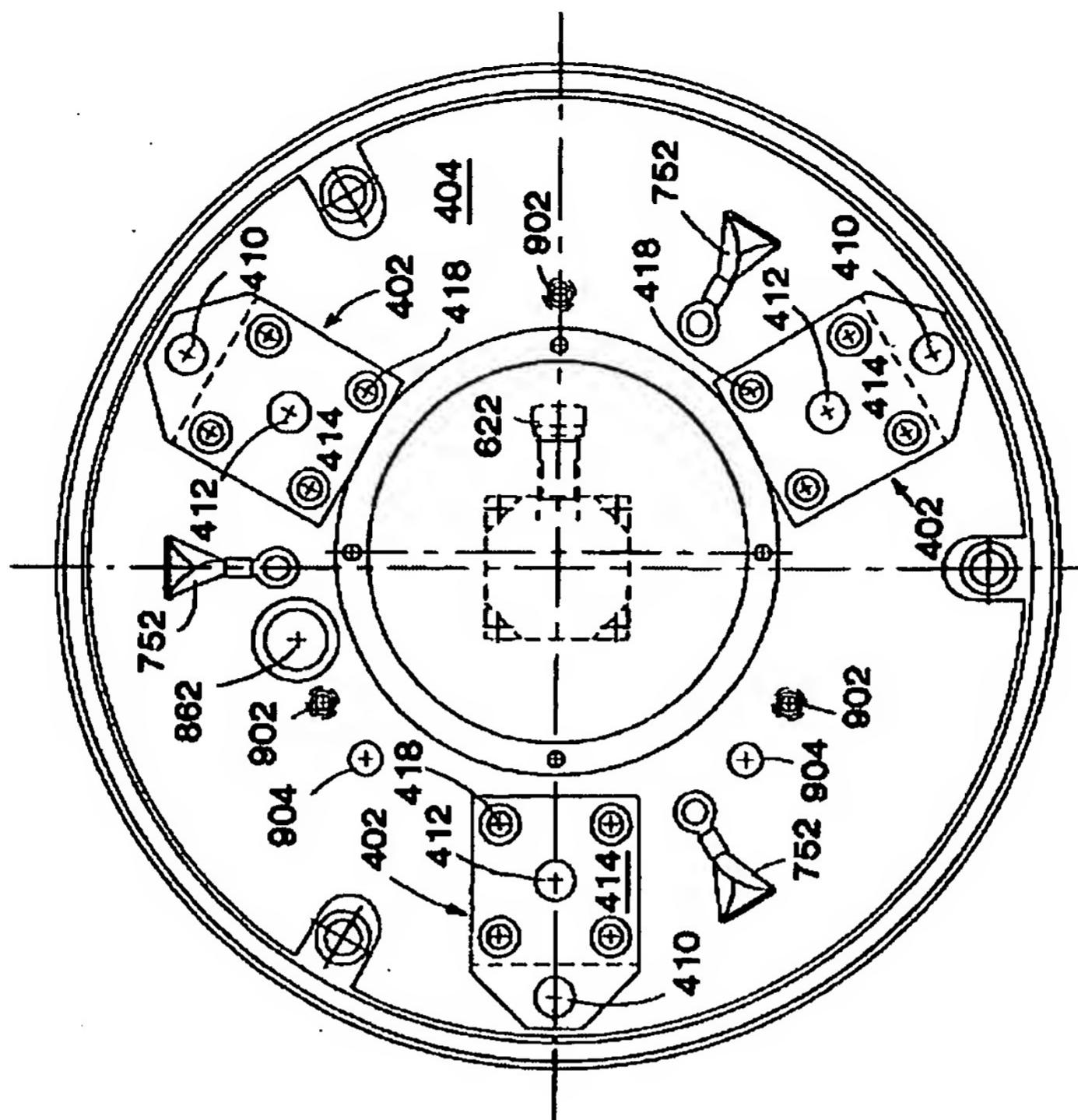
U9-PAT-NO: 6299751
DOCUMENT-IDENTIFIER: U9 6299751 B1
TITLE: Apparatus and method for plating wafers, substrates and other article

Brief Summary Text - BSTX (15):
A seventh aspect of the invention is an apparatus and method for plating a wafer that is particularly useful in improving the uniformity of the plating deposition across the surface of the wafer when the wafer is initially being plated. When the wafer is initially being plated, the surface resistance of the wafer is high due to the high resistive properties of the seed layer (e.g. copper seed layer). As a result, more of the plating is deposited where the cathode makes contact to the wafer (e.g. at the perimeter of the wafer). This aspect of the invention comprises providing a secondary cathode situated near the cathode contact of the wafer to reduce the plating rate near the cathode contact in response to a control voltage that is more negative than the cathode. The more negative voltage on the secondary cathode diverts plating ions that would otherwise be deposited near the cathode contact. The control voltage is selected to improve the uniformity of the plating deposition across the surface of the wafer.

Dates of Descriptions next = May (22):

In the preferred embodiment, the cathode contact comprises an electrical-conductive fluid, such as a mixture of sulfuric acid and de-ionized (DI) water. The conductive fluid is significantly advantageous because it provides a uniform contact along and within the exclusion zone (i.e. the contact has a uniform resistance along and within the exclusion zone). Because of the continuity of the cathode contact provided by the conductive fluid, a more uniform plating deposition and higher currents for increasing the plating rate results. Alternatively, a mechanical contact comprising a plurality of equally spaced contacts can be provided along and within the exclusion zone to

Detailed Description Text - DETX (64):
The advantage of using a conductive fluid versus a mechanical contact in making the cathode connection to the wafer 308 is that the fluid contact does not typically damage the wafer, whereas a mechanical contact tends to warp and/or deform the wafer. Another advantage of the fluid contact is that it provides a relatively large contact surface area since the contact is continuous throughout the "cathode contact area." For example, the two (2) millimeter wide cathode contact area amounts to approximately a two (2) square-inch surface area. That is substantial considering how small the width of the "cathode contact area" is. Because of the relatively large contact surface area, the resistance of the contact is relatively small. This increases the current carrying capacity of the contact, which can lead to much higher plating rates. Yet another advantage of the conductive fluid contact is that the electrical contact is more uniform throughout the "cathode contact area." This results in a more uniform plating deposition across the surface of the wafer.



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Document ID	Pages	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31	32	33	34	35	36	37	38	39	40	41	42	43	44	45	46	47	48	49	50	51	52	53	54	55	56	57	58	59	60	61	62	63	64	65	66	67	68	69	70	71	72	73	74	75	76	77	78	79	80	81	82	83	84	85	86	87	88	89	90	91	92	93	94	95	96	97	98	99	100	101	102	103	104	105	106	107	108	109	110	111	112	113	114	115	116	117	118	119	120	121	122	123	124	125	126	127	128	129	130	131	132	133	134	135	136	137	138	139	140	141	142	143	144	145	146	147	148	149	150	151	152	153	154	155	156	157	158	159	160	161	162	163	164	165	166	167	168	169	170	171	172	173	174	175	176	177	178	179	180	181	182	183	184	185	186	187	188	189	190	191	192	193	194	195	196	197	198	199	200	201	202	203	204	205	206	207	208	209	210	211	212	213	214	215	216	217	218	219	220	221	222	223	224	225	226	227	228	229	230	231	232	233	234	235	236	237	238	239	240	241	242	243	244	245	246	247	248	249	250	251	252	253	254	255	256	257	258	259	260	261	262	263	264	265	266	267	268	269	270	271	272	273	274	275	276	277	278	279	280	281	282	283	284	285	286	287	288	289	290	291	292	293	294	295	296	297	298	299	300	301	302	303	304	305	306	307	308	309	310	311	312	313	314	315	316	317	318	319	320	321	322	323	324	325	326	327	328	329	330	331	332	333	334	335	336	337	338	339	340	341	342	343	344	345	346	347	348	349	350	351	352	353	354	355	356	357	358	359	360	361	362	363	364	365	366	367	368	369	370	371	372	373	374	375	376	377	378	379	380	381	382	383	384	385	386	387	388	389	390	391	392	393	394	395	396	397	398	399	400	401	402	403	404	405	406	407	408	409	410	411	412	413	414	415	416	417	418	419	420	421	422	423	424	425	426	427	428	429	430	431	432	433	434	435	436	437	438	439	440	441	442	443	444	445	446	447	448	449	450	451	452	453	454	455	456	457	458	459	460	461	462	463	464	465	466	467	468	469	470	471	472	473	474	475	476	477	478	479	480	481	482	483	484	485	486	487	488	489	490	491	492	493	494	495	496	497	498	499	500	501	502	503	504	505	506	507	508	509	510	511	512	513	514	515	516	517	518	519	520	521	522	523	524	525	526	527	528	529	530	531	532	533	534	535	536	537	538	539	540	541	542	543	544	545	546	547	548	549	550	551	552	553	554	555	556	557	558	559	560	561	562	563	564	565	566	567	568	569	570	571	572	573	574	575	576	577	578	579	580	581	582	583	584	585	586	587	588	589	590	591	592	593	594	595	596	597	598	599	600	601	602	603	604	605	606	607	608	609	610	611	612	613	614	615	616	617	618	619	620	621	622	623	624	625	626	627	628	629	630	631	632	633	634	635	636	637	638	639	640	641	642	643	644	645	646	647	648	649	650	651	652	653	654	655	656	657	658	659	660	661	662	663	664	665	666	667	668	669	670	671	672	673	674	675	676	677	678	679	680	681	682	683	684	685	686	687	688	689	690	691	692	693	694	695	696	697	698	699	700	701	702	703	704	705	706	707	708	709	710	711	712	713	714	715	716	717	718	719	720	721	722	723	724	725	726	727	728	729	730	731	732	733	734	735	736	737	738	739	740	741	742	743	744	745	746	747	748	749	750	751	752	753	754	755	756	757	758	759	760	761	762	763	764	765	766	767	768	769	770	771	772	773	774	775	776	777	778	779	780	781	782	783	784	785	786	787	788	789	790	791	792	793	794	795	796	797	798	799	800	801	802	803	804	805	806	807	808	809	810	811	812	813	814	815	816	817	818	819	820	821	822	823	824	825	826	827	828	829	830	831	832	833	834	835	836	837	838	839	840	841	842	843	844	845	846	847	848	849	850	851	852	853	854	855	856	857	858	859	860	861	862	863	864	865	866	867	868	869	870	871	872	873	874	875	876	877	878	879	880	881	882	883	884	885	886	887	888	889	890	891	892	893	894	895	896	897	898	899	900	901	902	903	904	905	906	907	908	909	910	911	912	913	914	915	916	917	918	919	920	921	922	923	924	925	926	927	928	929	930	931	932	933	934	935	936	937	938	939	940	941	942	943	944	945	946	947	948	949	950	951	952	953	954	955	956	957	958	959	960	9

United States Patent [19]		[11] Patent Number: 5,368,711		[13] Date of Patent: Nov. 29, 1994	
Document ID	Patent No.	1	2	3	4
53	US 5503731 A	15	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
54	US 5486282 A	10	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
55	US 5459102 A	23	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
56	US 5440239 A	12	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
57	US 5437733 A	15	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
58	US 5376587 A	14	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
59	US 5368711 A	15	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>

Brief Summary Text - BSTX (6):
low contact resistance to previous and subsequent metallization steps

Brief Summary Text - BSTX (17):
Sputtered aluminum has electromigration and step coverage concerns.
Electromigration is an atomic transport mechanism which allows metal atoms to move due to an applied direct current resulting in the formation of voids in a metal line. These voids can cause an increase in line resistance and ultimately the opening of a line (open circuit). Step coverage describes the ability of the metal to fill contact and via holes. This directly affects the ability of the metal to carry current into and out of the contacts and vias. Poor step coverage may lead to the failure (open circuit) of the metal in the hole.

Brief Summary Text - BSTX (18): Subsequent processing (planarization and stacking vias on top of contacts) is also complicated by poor step coverage. Layering the aluminum with a more electromigration resistant metal or alloying the aluminum (forming new phases at the sensitive grain boundaries) are two approaches to reduce the probability of this failure mechanism. They are only partial solutions and introduce other problems such as complicating the metal etch step and increasing the sheet resistance of the metal. Solving the step coverage problem with standard sputtering techniques has also convincingly failed.

Detailed Description Text = DETX (6)

Referring back to FIG. 9, when the cathode (wafer) 5 is secured against the cathode gasket 3, electrolyte is excluded from contacting the area of the wafer contacting this cathode gasket 3 as well as the cathode wires 4. The cathode wires 4 penetrate the photoresist (where present) on the active side of the wafer and make ohmic contact with the nucleating layer/diffusion barrier (this would be the top surface observed in FIG. 5). Four separate cathode wires 4 (A, B, C and D) are employed to allow the confirmation of good contact between the wafer and electrode wires (by making a resistance measurement) before electrolyte is introduced into the cell and electrode deposition is initiated. A knowledge of the diffusion barrier/nucleation layer sheet resistance along with the cell geometry will allow the determination of good cathode/wire to cathode contact. Wires A and C may be checked followed by the

Claims Text - CITA (11):

5. The apparatus as in claim 3 further including a second cathode wire for producing electrical contact to said nucleation layer, so that good ohmic contact of said cathode wires can be ascertained by a resistance check across said first and second cathode wires subsequent to loading said semiconductor in said apparatus and prior to introduction of electrolyte into said container.

Current US Cross Reference Classification - CCXR (2) :
205/123

1880 (Aug 1) - 1881 (Aug 1) - 1882 (Aug 1) - 1883 (Aug 1)

Document ID	Page
US 5503731 A	15
US 5486282 A	10
US 5459102 A	23
US 5440239 A	12
US 5437733 A	15
US 5376587 A	14
US 5368711 A	15

U.S. Patent

Nov. 29, 1994

5,368,711

1

Brief summary Text - BETX (6):
low contact resistance to previous and subsequent metallization steps

Brief Summary Text - BSYX (17):
Sputtered aluminum has electromigration and step coverage concerns. Electromigration is an atomic transport mechanism which allows metal atoms to move due to an applied direct current resulting in the formation of voids in a metal line. These voids can cause an increase in line resistance and ultimately the opening of a line (open circuit). Step coverage describes the ability of the metal to fill contact and via holes. This directly affects the ability of the metal to carry current into and out of the contacts and vias. Poor step coverage may lead to the failure (open circuit) of the metal in the holes.

Brief Summary Text - BSTX (18):
 subsequent processing (planarization and stacking vias on top of contacts) is also complicated by poor stop coverage. Layering the aluminum with a more electromigration resistant metal or alloying the aluminum (forming new phases at the sensitive grain boundaries) are two approaches to reduce the probability of this failure mechanism. They are only partial solutions and introduce other problems such as complicating the metal etch step and increasing the sheet resistance of the metal. Solving the stop coverage problem with standard sputtering techniques has also convincingly failed.

Detailed Description Text - DETX (63):
 Referring back to FIG. 9, when the cathode (wafer) 5 is secured against the cathode gasket, andot. 3, electrolyte is excluded from contacting the area of the wafer contacting this cathode gasket 3 as well as the cathode wires 4. The cathode wires 4 penetrate the photoresist (where present) on the active side of the wafer and make ohmic contact with the nucleating layer/diffusion barrier (this would be the top surface observed in FIG. 5). Four separate cathode wires 4 (A, B, C and D) are employed to allow the confirmation of good contact between the wafer and electrode wires (by making a resistance measurement) before electrolyte is introduced into the cell and electrodeposition is initiated. A knowledge of the diffusion barrier/nucleation layer sheet resistance along with the cell geometry will allow the determination of good cathode wire to cathode contact. Wires A and C may be checked followed by the

Claims Text - CLTX (11):

5. The apparatus as in claim 3 further including a second cathode wire for producing electrical contact to said nucleation layer, so that good ohmic contact of said cathode wires can be ascertained by a resistance check across said first and second cathode wires subsequent to loading said semiconductor in.

Current US Cross Reference Classification - CCXR (2):
205/122

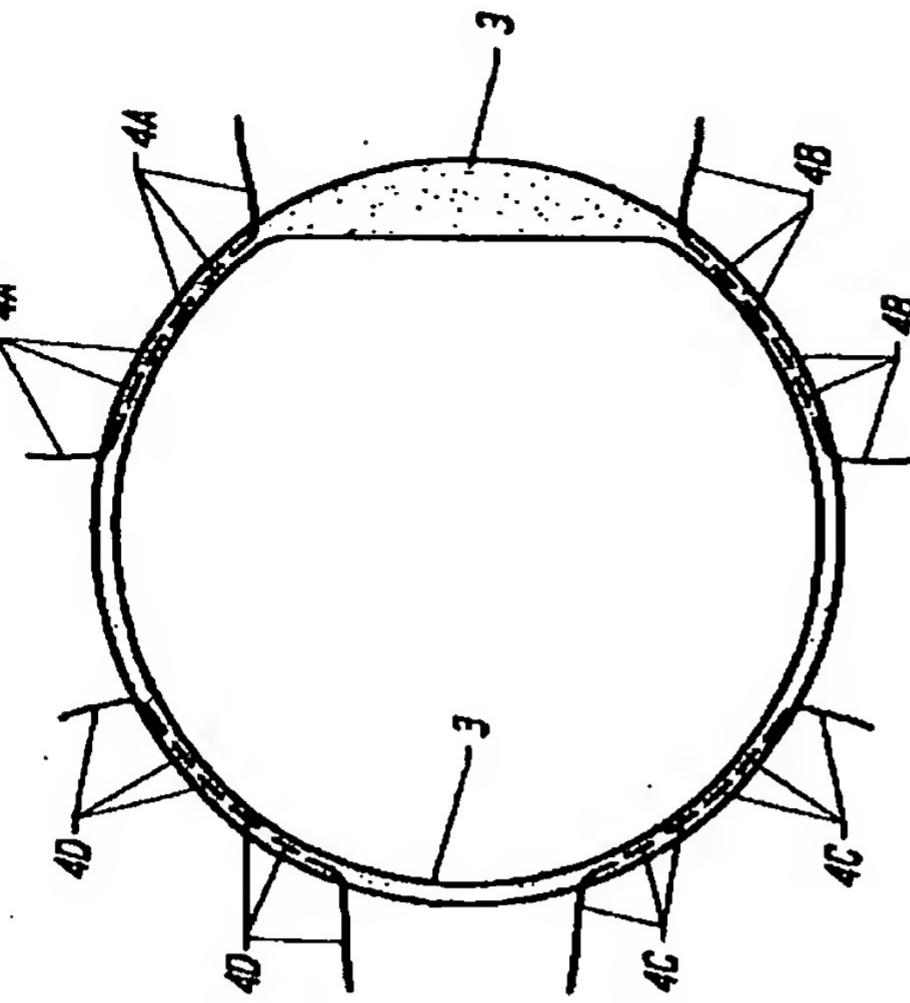
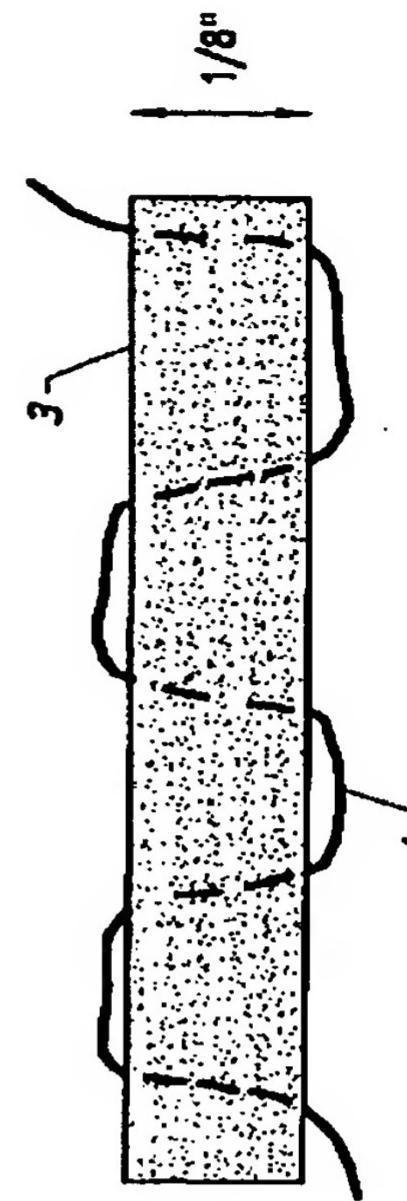


FIG. 10A



ETG 10B

small current flows.

[0089] The measuring device 424 is connected to the controller 318. The measuring device 424 sends obtained current value data between each contact pin 413a and each probe 418 to the controller 318. The controller 318 determines the contact (connection) state of each contact pin 413a from the current quantities.

[0090] For example, the controller 318 determines that the contact state of contact pin 413a is normal when the current value between the contact pin 413a and the corresponding probe 418 is more than a predetermined value. While, in the case where the current value is below the predetermined value, the controller 318 determines that the contact state of contact pin 413a is abnormal.

[0091] The controller 318 performs control of the overall apparatus such as continuation of plating or stop processing, and the like based on the determination result. This makes it possible to check the contact state of each contact pin 413e without fail, and to perform plating with high reliability.

[0092] An explanation will be next given of a plating method using the above-structured plating unit 104. First, the contact state of contact 413a of the cathode electrode 413 is checked before the wafer W is plated as illustrated in FIG. 9A, the pressing tool 416 rises in the holding section 411. At this time, the pressing tool 416, the contact pin 413a, and the seal section 415 are arranged in the following order from top to bottom.

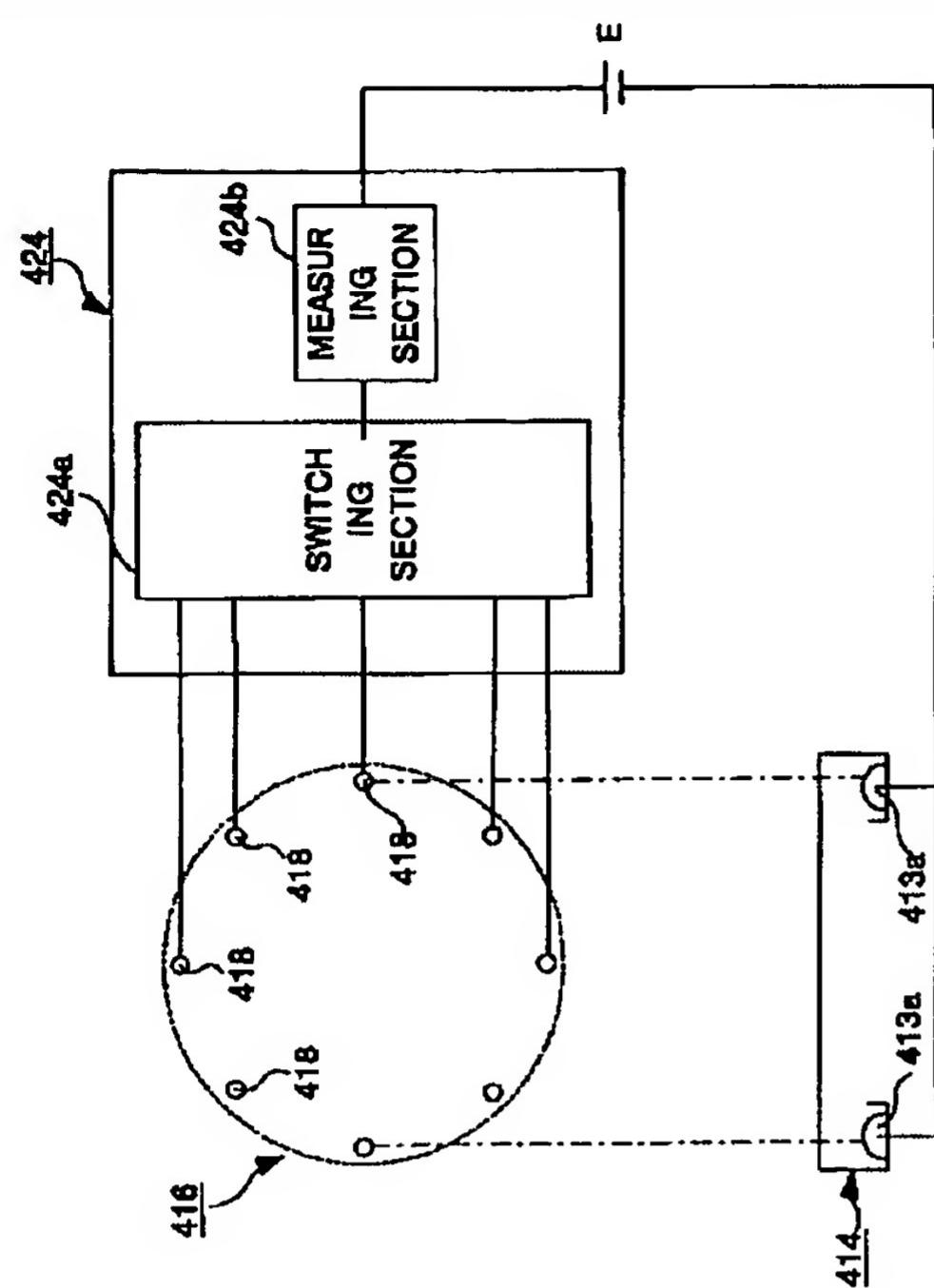
[0093] Next, as illustrated in FIG. 9B, the pressing tool 416 moves down. At the position corresponding to the contact pin 413a of the lower surface of the pressing tool 416, the first concave portion 416a is formed. At the position corresponding to the seal section 415 of the lower surface of the pressing tool 416, the second concave portion 416b is formed. Accordingly, when the pressing tool 416 moves down, the contact pin 413a is contained in the first concave portion 416a and the seal section 415 is contained in the second concave portion 416b. At this time, the probe 418 in the first concave portion 416a and the contact pin 413a are in contact with each other. In this state, the measuring device 424 measures the electrical resistance between each pair of contact pin 413a of the cathode electrode 413 and probe 418 sequentially.

[0094] The controller 318 determines that the contact state of contact pin 413a is normal when the current value between the contact pin 413a and the corresponding probe 418 is more than a predetermined value. While, in the case where the current value is below the predetermined value, the controller 318 determines that the contact state of contact pin 413a is abnormal. The controller 318 stops plating when determining that the contact state is abnormal and continues plating when determining that the contact state is normal.

[0095] After checking contact (connection), the pressing tool 416 rises and a space is formed among the pressing tool 416, the contact pin 413a, and the seal section 415. Then, as illustrated in FIG. 9C, the second wafer transfer apparatus 213 loads the wafer W into the plating unit 104 through the space and mounts the wafer W on the contact pins 413a and the seal section 415.

[0096] sequentially, as illustrated in FIG. 9D, the pressing tool 416 moves down and presses the wafer W from the above. This fixes the wafer W to be adhered to the steel section 415. Next, the holding section 414 moves down and holds the state that the pressing tool 416 presses the wafer W.

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File View Edit Tools Window Help

Drafts Pending Active

L1: (609) (205/123) or (205/157).CCLS.

L2: (1479716) contact or contacts

L3: (809533) resistance

L4: (132389) 12 same 13

LS: (108) 14 and 11

L7: (1171047) measure or measures or measured or measuring

L8: (414681) measurement or measurement

L9: (1220894) 17 or 18

L10: (38669) 13 near3 19

L11: (17) 110 and 11

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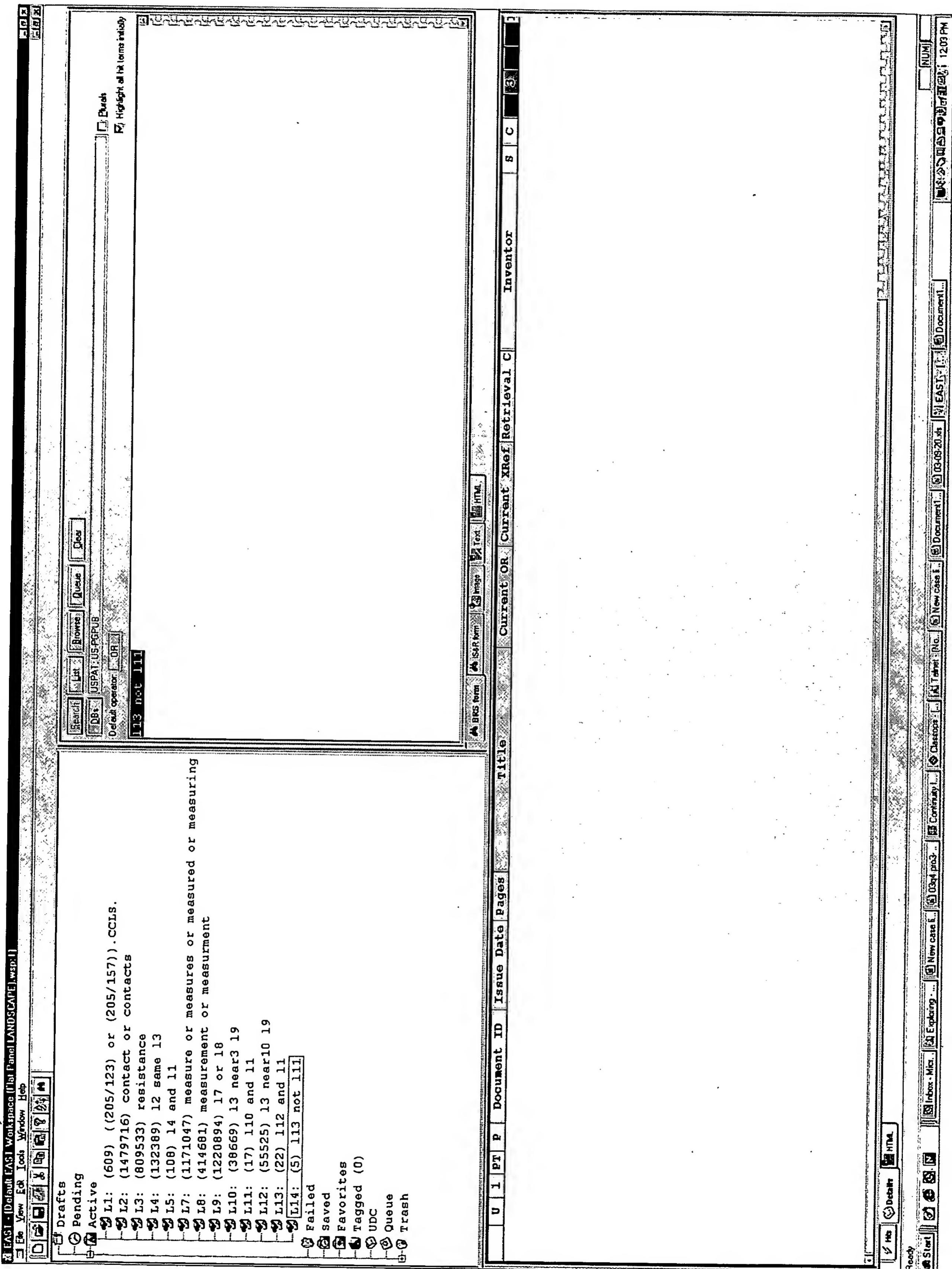
Title	Current OR	Current XRef Retrieval C	Inventor	S	C	R

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L1: (609) (205/123) or (205/157).CCLS.

L2: (1479716) contact or contacts

L3: (809533) resistance

L4: (132389) 12 same 13

L5: (108) 14 and 11

L7: (1171047) measure or measures or measured or measuring

L8: (414681) measurement or measurement

L9: (1220894) 17 or 18

L10: (38669) 13 near3 19

L11: (17) 110 and 11

L12: (55525) 13 near10 19

L13: (22) 112 and 11

L14: (5) 113 not 111

L15: (331) (205/81-85).CCLS.

L16: (28) 112 and 115

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112 and 115

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Title				Inventor			Current OR			XRef Retrieval C		
U	V	1	PT	P	Document ID	Issue Date	Pages		S	C	G	J

<input checked="" type="checkbox"/> Has	<input checked="" type="checkbox"/> Database	<input checked="" type="checkbox"/> HTML
Ready		
<input checked="" type="checkbox"/> Start	<input checked="" type="checkbox"/> Stop	<input checked="" type="checkbox"/> Reset
<input checked="" type="checkbox"/> Indoor - Mic.		
<input checked="" type="checkbox"/> Exporting ...		
<input checked="" type="checkbox"/> New case in...		
<input checked="" type="checkbox"/> Document ...		
<input checked="" type="checkbox"/> EAST		
<input checked="" type="checkbox"/> Continuity ...		
<input checked="" type="checkbox"/> Clearcut ...		
<input checked="" type="checkbox"/> Total : (No.)		
<input checked="" type="checkbox"/> Date : 03-08-2018		
<input checked="" type="checkbox"/> Document ...		
<input checked="" type="checkbox"/> 12:16 PM		
NUM		

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 Drafts Pending Active

L1: (609) ((205/123) or (205/157)) .CCLS.

L2: (1479716) contact or contacts

L3: (809533) resistance

L4: (132389) 12 same 13

L5: (108) 14 and 11

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L10: (38669) 13 near3 19

L11: (17) 110 and 11

L12: (55525) 13 near10 19

L13: (22) 112 and 11

L14: (5) 113 not 111

L15: (331) (205/81-85) .CCLS.

L16: (28) 112 and 115

L17: (33) 14 and 115

L18: (27) 117 not 15

L19: (780) (204/224R) .CCLS.

L20: (17) 112 and 119

L21: (16) 120 not (113 or 116)

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| 348 | 349 | 350 | 351 | 352 | 353 | 354 | 355 | 356 | 357 | 358 | 359 | 360 | 361 | 362 | 363 | 364 | 365 | 366 | 367 | 368 | 369 | 370 | 371 | 372 | 373 | 374 | 375 | 376 | 377 | 378 | 379 | 380 | 381 | 382 | 383 | 384 | 385 | 386 | 387 | 388 | 389 | 390 | 391 | 392 | 393 | 394 | 395 | 396 | 397 | 398 | 399 | 400 | 401 | 402 | 403 | 404 | 405 | 406 | 407 | 408 | 409 | 410 | 411 | 412 | 413 | 414 | 415 | 416 | 417 | 418 | 419 | 420 | 421 | 422 | 423 | 424 | 425 | 426 | 427 | 428 | 429 | 430 | 431 | 432 | 433 | 434 | 435 | 436 | 437 | 438 | 439 | 440 | 441 | 442 | 443 | 444 | 445 | 446 | 447 | 448 | 449 | 450 | 451 | 452 | 453 | 454 | 455 | 456 | 457 | 458 | 459 | 460 | 461 | 462 | 463 | 464 | 465 | 466 | 467 | 468 | 469 | 470 | 471 | 472 | 473 | 474 | 475 | 476 | 477 | 478 | 479 | 480 | 481 | 482 | 483 | 484 | 485 | 486 | 487 | 488 | 489 | 490 | 491 | 492 | 493 | 494 | 495 | 496 | 497 | 498 | 499 | 500 | 501 | 502 | 503 | 504 | 505 | 506 | 507 | 508 | 509 | 510 | 511 | 512 | 513 | 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847 | 848 | 849 | 850 | 851 | 852 | 853 | 854 | 855 | 856 | 857 | 858 | 859 | 860 | 861 | 862 | 863 | 864 | 865 | 866 | 867 | 868 | 869 | 870 | 871 | 872 | 873 | 874 | 875 | 876 | 877 | 878 | 879 | 880 | 881 | 882 | 883 | 884 | 885 | 886 | 887 | 888 | 889 | 890 | 891 | 892 | 893 | 894 | 895 | 896 | 897 | 898 | 899 | 900 | 901 | 902 | 903 | 904 | 905 | 906 | 907 | 908 | 909 | 910 | 911 | 912 | 913 | 914 | 915 | 916 | 917 | 918 | 919 | 920 | 921 | 922 | 923 | 924 | 925 | 926 | 927 | 928 | 929 | 930 | 931 | 932 | 933 | 934 | 935 | 936 | 937 | 938 | 939 | 940 | 941 | 942 | 943 | 944 | 945 | 946 | 947 | 948 | 949 | 950 | 951 | 952 | 953 | 954 | 955 | 956 | 957 | 958 | 959 | 960 | 961 | 962 | 963 | 964 |
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9/2003 10/010.954

2020 : 01st and 03rd Workshops [Final Panel | ANNUAL REPORT]

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	Document ID	Pages	1	3	5	7	9	U	S	C	P	Kind Codes	Source
1	US 6551484 B2	46	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT							
2	US 6517689 B1	22	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT						
3	US 6500317 B1	17	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT						
4	US 6447668 B1	107	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT							
5	US 6428681 B1	9	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT							
6	US 6413389 B1	19	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT							
7	US 6267855 B1	31	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	USPAT						

UG-PAT-NO: 6500317
DOCUMENT-IDENTIFIER: US 6500317 B1
TITLE: Plating apparatus for detecting the conductivity between plating contacts on a substrate

Brief Summary Text - BSTX (9):
To solve the above mentioned subject matter, there is provided a method for confirming conductivity state between a plating jig having a plurality of conducting pins and a substrate to be plated having a conductive film, the substrate being mounted on the plating jig having a plurality of conducting pins such that the conducting pins contact the conductive film thereon, the method comprising: disposing the conducting pins of the plating jig being electrically separated independently with each other; attaching an end of reverse-current blocking diode to wiring connecting to the conducting pins, and connecting to the other ends of the reverse-current blocking diodes together to wiring connecting to a plating power source; and measuring an electrical resistance between the wiring so as to measure the electrical resistance between conducting pins of the plating jig.

Brief Summary Text - B9T9 (10):
According to another aspect of the present invention, the conductivity state detector may comprise a contact resistance measuring device for measuring contact resistance between the feeder contacts and the conductive area on the surface of the substrate and detects the conductivity state of the feeder contacts based on the contact resistance measured by the contact resistance measuring device.

Drawing Description Text - DRTX (10): FIG. 9 shows an example of a basic circuit construction for measuring

Drawing Description Text - DRTX (12):
FIG. 11 shows the wiring configuration for measuring contact resistance at
the feeder contacts and supplying current for heating.

Drawing Description Text - DRDX (13) :
FIG. 12 shows an example circuit construction for a contact resistance
measuring device disposed at the feeder contacts; and

(12) United States Patent (10) Patent No.: US 6,500,317 B1
Yoshioka et al. (45) Date of Patent: Dec. 31, 2002

(12) United States Patent
Yoshioka et al.

(10) Patent No.: US 6,500,317 B1
(45) Date of Patent: Dec. 31, 2002

(54) PLATING APPARATUS FOR DETECTING THE CONDUCTIVITY BETWEEN PLATING CONTACTS ON A SUBSTRATE (58) Field of Search 204/229.8, 230.8, 204/228.1, 224 R, 297.05, 297.14, 226.7; 205/113

(75) Inventors:	Junichiro Yoshioka; Satoshi Sendai; Abeishi Chono; Mitsuo Teda; Akihisa Hongo; Yoshitaka Mukaiyama; Kenya Tomioke; Akira Ogata; Kenichi Suruki, all of Tokyo; Naomitsu Ozawa, Kanagawa, all of (JP)	(56)	U.S. PATENT DOCUMENTS	References Cited
			6,004,440 A * 12/1999 Hansen et al.	
			6,071,388 A * 6/2000 Uzab	204/297 R
			6,071,399 A * 6/2000 Van der Bergs et al. ..	205/337
			6,139,712 A 10/2000 Paton et al.	

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(73) Assignee: Ebara Corporation, Tokyo (JP)	(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 156(b) by 0 days.	JP	50-8733 56-93900	1/1975 7/1981 1977-08
		JP		

(21) Appl. No.:	09/581,761	JP	5-320377	127193
(22) PCT Filed:	Dec. 16, 1998	JP	3003657	871994

PCT/JP98/04672
(85) PCT No.: § 371 (e)(1),
 (2), (4) Date: Jun. 16, 2000
(86) Primary Examiner—Nam Nguyen
 Assistant Examiner—Wesley A. Nicolas
 (74) Attorney, Agent or Firm—Wenderoth, Lind & Ponack,
 L.L.P.

(87) PCT Pub. No.: WO99/31304
(88) ABSTRACT

The present invention provides a conductivity sensing device capable of detecting the conductivity (contact state) of the plurality of feeder contacts connecting the conductive area of the substrate, and a plating apparatus capable of forming a plating film of uniform thickness by supplying a uniform plating current through a plurality of feeder contacts.

5 Claims, 12 Drawing Sheets
204,730.8

17

This diagram illustrates a complex electrical circuit with several components and their interconnections. The circuit includes two main vertical lines on the left and right sides, with various horizontal and diagonal branches connecting them. Key components include four diodes (represented by triangles) and two circular symbols containing the letter 'C'. The connections are labeled with codes such as 1-3, 2-2, 3-1, 4-1, 1-2, 4-2, 2-3, 3-2, 1-4, 3-3, 2-4, and 12. The labels are placed near the corresponding connection points or components.



LASI - Detach LASI Workspace [flat Panel LANDSCAPE.wsp:1]

A screenshot of the FAS! WorkSpace software interface. The title bar reads "FAS! - [Default FAS! Workspace (Flat Panel LANDSCAPE).wsp;1]". The menu bar includes "File", "Edit", "View", "Edit", "Tools", "Window", and "Help". The main workspace displays a landscape-oriented panel design with various components and labels like "Panel", "Base", and "Trim".

	Active	Failed	Not Active
L1:	(609) ((205/123) or (205/157)).CCLS.		
L2:	(1479716) contact or contacts		
L3:	(809533) resistance		
L4:	(132389) 12 same 13		
L5:	(108) 14 and 11		
L7:	(1171047) measure or measures or measured or measuring		
L8:	(414681) measurement or measurement		
L9:	(1220894) 17 or 18		
L10:	(38669) 13 near3 19		
L11:	(17) 110 and 11		
L12:	(55525) 13 near10 19		
L13:	(22) 112 and 11		
L14:	(5) 113 not 111		
L15:	(331) (205/81-85).CCLS.		
L16:	(28) 112 and 115		
L17:	(33) 14 and 115		
L18:	(27) 117 not 15		
L19:	(780) (204/224R).CCLS.		
L20:	(17) 112 and 119		
L21:	(16) 120 not (113 or 116)		
L22:	(1174) (204/228.1-230.8).CCLS.		
L23:	(57) 112 and 122		
L24:	(48) 123 not (113 or 116 or 120)		
L25:	(87) 14 and 119		
L26:	(78) 125 not (15 or 117)		
L28:	(63) 126 not (113 or 116 or 120 or 123)		
L29:	(94) 14 and 122		
L30:	(75) 129 not (15 or 117 or 125)		
L31:	(56) 130 not (113 or 116 or 120 or 123)		

ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍	ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍
ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍	ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍
ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍	ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍
ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍	ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍
ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍	ମାତ୍ରାବିନ୍ଦି	କେଣ୍ଟିନ୍ ପାର୍କ୍

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3 US 6475369 B1	30	□	□	□	□	□	□	USPAT	USPAT
4 US 6444111 B1	62	□	□	□	□	□	□	USPAT	USPAT
5 US 6436249 B1	54	□	□	□	□	□	□	USPAT	USPAT
6 US 6379521 B1	25	□	□	□	□	□	□	USPAT	USPAT
7 US 6355153 B1	24	□	□	□	□	□	□	USPAT	USPAT

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TITLE:

Clamshell apparatus for electrochemically treating semiconductor wafers

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TITLE:

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TITLE:

Clamshell apparatus for electrochemically treating semiconductor wafers

(12) **United States Patent**

(10) Patent No.: **US 6,436,249 B1**

(45) Date of Patent: ***Aug 20, 2002**

(11) Inventor: **Evan E. Patton et al.**

(54) **CLAMSHELL APPARATUS FOR ELECTROCHEMICALLY TREATING SEMICONDUCTOR WAFERS**

(75) Inventors: Evan E. Patton, Portland, Wayne Fetter, Canby, both of OR (US)

(73) Assignee: **Novellus Systems, Inc., San Jose, CA (US)**

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

This patent is subject to a terminal disclaimer.

(21) Appl. No.: 09/576,843

(22) Filed: May 17, 2000

Related U.S. Application Data

(63) Continuation of application No. 08/969,964, filed on Nov. 13, 1997, now Pat. No. 6,156,167.

(31) Int. Cl. 7 C23D 17/00; C23C 7/00; C25B 9/00

(52) U.S. Cl. 204/212; 204/270

(58) Field of Search, 204/212, 270

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(List continued on next page)

11 Claims, 48 Drawing Sheets

ABSTRACT

An apparatus for electroplating a wafer surface includes a cup having a central aperture defined by an inner perimeter, contacts, a compliant seal adjacent the inner perimeter, a compliant seal adjacent the central aperture, and a cone attached to a rotatable spindle. The compliant seal forms a seal with the perimeter region of the wafer surface preventing plating solution from contaminating the wafer edge, wafer backside and the contact area. As a further measure to prevent contamination, the region behind the compliant seal is pressurized. By rotating the wafer during the electroplating, bubble entrapment on the wafer surface is prevented. Further, the contacts can be arranged into banks of contacts and the resistivity between banks can be tested to detect poor electrical connections between the contacts and the wafer surface.

<img alt="A detailed technical drawing of a clamshell apparatus for electrochemically treating semiconductor wafers. The diagram shows a top view of a rectangular frame with various ports and components. Labels include 301, 302, 303, 304, 305, 306, 307, 308, 309, 310, 311, 312, 313, 314, 315, 316, 317, 318, 319, 320, 321, 322, 323, 324, 325, 326, 327, 328, 329, 330, 331, 332, 333, 334, 335, 336, 337, 338, 339, 340, 341, 342, 343, 344, 345, 346, 347, 348, 349, 350, 351, 352, 353, 354, 355, 356, 357, 358, 359, 360, 361, 362, 363, 364, 365, 366, 367, 368, 369, 370, 371, 372, 373, 374, 375, 376, 377, 378, 379, 380, 381, 382, 383, 384, 385, 386, 387, 388, 389, 390, 391, 392, 393, 394, 395, 396, 397, 398, 399, 400, 401, 402, 403, 404, 405, 406, 407, 408, 409, 410, 411, 412, 413, 414, 415, 416, 417, 418, 419, 420, 421, 422, 423, 424, 425, 426, 427, 428, 429, 430, 431, 432, 433, 434, 435, 436, 437, 438, 439, 440, 441, 442, 443, 444, 445, 446, 447, 448, 449, 450, 451, 452, 453, 454, 455, 456, 457, 458, 459, 460, 461, 462, 463, 464, 465, 466, 467, 468, 469, 470, 471, 472, 473, 474, 475, 476, 477, 478, 479, 480, 481, 482, 483, 484, 485, 486, 487, 488, 489, 490, 491, 492, 493, 494, 495, 496, 497, 498, 499, 500, 501, 502, 503, 504, 505, 506, 507, 508, 509, 510, 511, 512, 513, 514, 515, 516, 517, 518, 519, 520, 521, 522, 523, 524, 525, 526, 527, 528, 529, 530, 531, 532, 533, 534, 535, 536, 537, 538, 539, 540, 541, 542, 543, 544, 545, 546, 547, 548, 549, 550, 551, 552, 553, 554, 555, 556, 557, 558, 559, 560, 561, 562, 563, 564, 565, 566, 567, 568, 569, 570, 571, 572, 573, 574, 575, 576, 577, 578, 579, 580, 581, 582, 583, 584, 585, 586, 587, 588, 589, 590, 591, 592, 593, 594, 595, 596, 597, 598, 599, 600, 601, 602, 603, 604, 605, 606, 607, 608, 609, 610, 611, 612, 613, 614, 615, 616, 617, 618, 619, 620, 621, 622, 623, 624, 625, 626, 627, 628, 629, 630, 631, 632, 633, 634, 635, 636, 637, 638, 639, 640, 641, 642, 643, 644, 645, 646, 647, 648, 649, 650, 651, 652, 653, 654, 655, 656, 657, 658, 659, 660, 661, 662, 663, 664, 665, 666, 667, 668, 669, 670, 671, 672, 673, 674, 675, 676, 677, 678, 679, 680, 681, 682, 683, 684, 685, 686, 687, 688, 689, 690, 691, 692, 693, 694, 695, 696, 697, 698, 699, 700, 701, 702, 703, 704, 705, 706, 707, 708, 709, 710, 711, 712, 713, 714, 715, 716, 717, 718, 719, 720, 721, 722, 723, 724, 725, 726, 727, 728, 729, 730, 731, 732, 733, 734, 735, 736, 737, 738, 739, 740, 741, 742, 743, 744, 745, 746, 747, 748, 749, 750, 751, 752, 753, 754, 755, 756, 757, 758, 759, 760, 761, 762, 763, 764, 765, 766, 767, 768, 769, 770, 771, 772, 773, 774, 775, 776, 777, 778, 779, 770, 771, 772, 773, 774, 775, 776, 777, 778, 779, 780, 781, 782, 783, 784, 785, 786, 787, 788, 789, 780, 781, 782, 783, 784, 785, 786, 787, 788, 789, 790, 791, 792, 793, 794, 795, 796, 797, 798, 799, 790, 791, 792, 793, 794, 795, 796, 797, 798, 799, 800, 801, 802, 803, 804, 805, 806, 807, 808, 809, 800, 801, 802, 803, 804, 805, 806, 807, 808, 809, 810, 811, 812, 813, 814, 815, 816, 817, 818, 819, 810, 811, 812, 813, 814, 815, 816, 817, 818, 819, 820, 821, 822, 823, 824, 825, 826, 827, 828, 829, 820, 821, 822, 823, 824, 825, 826, 827, 828, 829, 830, 831, 832, 833, 834, 835, 836, 837, 838, 839, 830, 831, 832, 833, 834, 835, 836, 837, 838, 839, 840, 841, 842, 843, 844, 845, 846, 847, 848, 849, 840, 841, 842, 843, 844, 845, 846, 847, 848, 849, 850, 851, 852, 853, 854, 855, 856, 857, 858, 859, 850, 851, 852, 853, 854, 855, 856, 857, 858, 859, 860, 861, 862, 863, 864, 865, 866, 867, 868, 869, 860, 861, 862, 863, 864, 865, 866, 867, 868, 869, 870, 871, 872, 873, 874, 875, 876, 87

